

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815 Examiner: Chris C. CHU # 11/2 #Ds 5/1/3/1

Re PATENT APPLICATION Of:

Applicant(s): Tadashi YAMAGUCHI

Serial No.: 10/020,153

Filed:

December 18, 2001

For:

SEMICONDUCTOR DEVICE

Docket No.:

KAN 137

INFORMATION DISCLOSURE STATEMENT

April 21, 2003

Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(4), i.e., before the mailing of a first Office Action and after the filing of a Request for Continued Examination (RCE).

Attached is a copy of one (1) Japanese Patent document cited in connection with a Japanese counterpart application. Any relevance of the foreign-language document can be gleaned from the attached English-language Abstract. The publication is listed on the attached Form PTO-1449.

Consideration of the submitted document is respectfully requested.

Robert H. Berdo, Jr. Registration No. 38,075

RABIN & BERDO, PC Customer No. 23995

Telephone: 202-371-8976

Facsimile: 202-408-0924

2800 MAIL R

RECEIVED

RHB:crh

FEE ENCLOSED:\$ ()
Pleas charge any further
fee t our D posit Account
No. 18,0003